

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2366	(tungsten near nitride) with ((barrier or diffusion or intermediate or adhesion) near (layer or coating or film))	US-PGPUB; USPAT	OR	ON	2007/12/16 15:15
L2	44508	copper near (film or layer or coating)	US-PGPUB; USPAT	OR	ON	2007/12/16 15:15
L3	223119	vapor adj deposition or cvd	US-PGPUB; USPAT	OR	ON	2007/12/16 15:16
L4	54542	organometallic or metalorganic or metallorganic	US-PGPUB; USPAT	OR	ON	2007/12/16 15:16
L5	5909	3 same 4	US-PGPUB; USPAT	OR	ON	2007/12/16 15:16
L6	75	2 same 5	US-PGPUB; USPAT	OR	ON	2007/12/16 15:17
L7	14	1 and 6	US-PGPUB; USPAT	OR	ON	2007/12/16 17:39
L8	1	"20020053519".pn. and nitride	US-PGPUB; USPAT	OR	ON	2007/12/16 15:34
L9	1	"20040234704".pn.	US-PGPUB; USPAT	OR	ON	2007/12/16 15:40
L10	1	9 and substantially	US-PGPUB; USPAT	OR	ON	2007/12/16 15:43
L11	1	9 and r5	US-PGPUB; USPAT	OR	ON	2007/12/16 15:43
L12	14	seed and 7	US-PGPUB; USPAT	OR	ON	2007/12/16 17:49
L13	1	"6150268".pn.	US-PGPUB; USPAT	OR	ON	2007/12/16 17:49